



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazuto HIROKAWA et al.

Serial No. 10/617,794

Filed July 14, 2003

SUBSTRATE POLISHING APPARATUS

: **Confirmation No. 4091**

: Docket No. 2003-0961A

: **ATTN: BOX MISSING PARTS**

:

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2003-138479, filed May 16, 2003, Japanese Patent Application No. 2003-138496, filed May 16, 2003, Japanese Patent Application No. 2003-138782, filed May 16, 2003, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Applications are submitted herewith.

Respectfully submitted,

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January 26, 2004

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